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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/668,064	09/25/2000	HIROKI SUZUKAWA	684.3077	1752
•	90 08/14/2003			
FITZPATRICK CELLA HARPER & SCINTO 30 ROCKEFELLER PLAZA NEW YORK, NY 10112			EXAMINER KIM, PETER B	
			2851	
•	*		DATE MAILED: 08/14/2003	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application N .	Applicant(s)				
Office Action Comments	09/668,064	SUZUKAWA, HIROKI				
Office Action Summary	Examiner	Art Unit				
	Peter B. Kim	2851				
The MAILING DATE of this communication app Period for Reply	ears n the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). Status	within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONEI	ely filed s will be considered timely. the mailing date of this communication. C (35 U.S.C. § 133).				
1) Responsive to communication(s) filed on 18 J	Responsive to communication(s) filed on 18 June 2003.					
2a) This action is FINAL . 2b) ⊠ Thi	s action is non-final.	•				
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. Disposition of Claims						
4)⊠ Claim(s) <u>1-33</u> is/are pending in the application.	,					
	4a) Of the above claim(s) is/are withdrawn from consideration.					
5)⊠ Claim(s) <u>1-30</u> is/are allowed.						
6)⊠ Claim(s) <u>31-33</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/or	· election requirement.					
Application Papers	·	•				
9) The specification is objected to by the Examiner						
10) The drawing(s) filed on is/are: a) □ accep	ted or b) objected to by the Exar	miner.				
Applicant may not request that any objection to the	e drawing(s) be held in abeyance. Se	ee 37 CFR 1.85(a).				
11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.						
If approved, corrected drawings are required in reply to this Office action.						
12) The oath or declaration is objected to by the Exa	aminer.					
Priority under 35 U.S.C. §§ 119 and 120						
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).						
a)⊠ All b)□ Some * c)□ None of:						
 Certified copies of the priority documents 	s have been received.					
2. Certified copies of the priority documents	2. Certified copies of the priority documents have been received in Application No					
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 						
14) Acknowledgment is made of a claim for domestic	•					
a) The translation of the foreign language pro						
15) Acknowledgment is made of a claim for domestic	c priority under 35 U.S.C. §§ 120	and/or 121.				
Attachment(s)						
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 	5) Notice of Informal F	Patent Application (PTO-152)				

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after allowance or after an Office action under *Ex Parte Quayle*, 25 USPQ 74, 453 O.G. 213 (Comm'r Pat. 1935). Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on June 18, 2003 has been entered.

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) do not apply to the examination of this application as the application being examined was not (1) filed on or after November 29, 2000, or (2) voluntarily published under 35 U.S.C. 122(b). Therefore, this application is examined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

2. Claims 31-33 are rejected under 35 U.S.C. 102(e) as being anticipated by Uzawa (6,342,942).

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Uzawa discloses in Figures 2 and 3, an exposure method, a device manufacturing method and exposure apparatus including first plural shot processes to be made to a substrate and a second shot process to be made to the substrate after completion of the first shot processes with a first step for determining the processing order in a first sample shot process, and a second step for determining the processing order in a second sample shot process to be made after the first sample shot process; wherein the determination is made under a condition that an interval between a shot to be processed last in the first sample shot process and a shot to be processed first in the second sample shot process is shortened. In Uzawa, the order of exposure process is shown with solid arrows in Fig. 2 is the first shot process and the order of exposure process shown with sold arrows in Fig. 3 is the second shot process, and the processing order of the shots are determined in which the distance between two shots to be processed consecutively by the first and second processes, respectively.

Allowable Subject Matter

Claims 1-30 are allowed.

None of the prior art of record teaches or discloses determining the processing order in the first and second sample shot processes so as to shorten the interval between the last shot of the first sample shot process and the first shot of the second sample shot process. Also, none of the prior art of record teaches or discloses determining the processing order in the sample shot process and the exposure process so as to shorten the interval between the last shot in the sample shot process and the first shot in the exposure process.

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Remarks

Unlike claims 1-30, claims 31-33 make no distinction between exposure process and the sample shot process.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Peter Kim whose telephone number is (703) 305-0105. The examiner can normally be reached on Monday-Thursday from 8:30 AM to 6:00 PM. The examiner can also be reached on alternate Fridays during the same hours.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Russ Adams can be reached on 703 308 2847. The fax phone numbers for the organization where this application or proceeding is assigned is 703 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703 306- 3431.

Peter B. Kim
Patent Examiner

August 5, 2003